Vol. 21, Iss. 2 (2023)

Focus on e-JSSNT

No. 185
May 2023

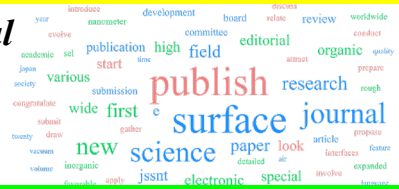
e-JSSNT 創刊20周年記念特集号

Progress of Vacuum and Surface Science and Technology in the Early 21st Century —the 20th Anniversary of *e-JSSNT*—

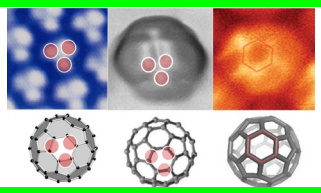
電子ジャーナル「*e-Journal of Surface Science and Nanotechnology*」創刊20周年に寄せて **Preface**

On the 20 Year Anniversary of *e-Journal of Surface Science and Nanotechnology*

Ayahiko Ichimiya
Vol.21, Iss. 2, p. 84 (2023)



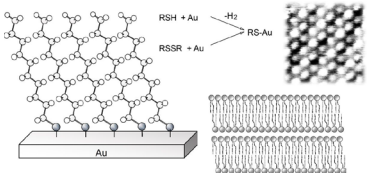
走査型プローブ顕微鏡研究の進歩 **Review**



Advances in Scanning Probe Microscopy Research

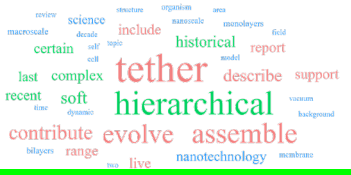
Tomihiro Hashizume
Vol.21, Iss. 2, pp.85-91 (2023)

無機表面から有機表面へ： ソフトナノテクノロジーの進展 **Review**

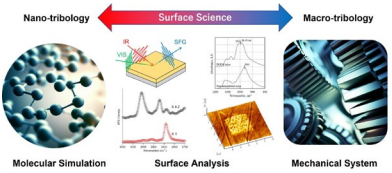


From Inorganic to Organic Surfaces: Progress of Soft Nanotechnology

Kaoru Tamada
Vol. 21, Iss. 2, pp. 92-97 (2023)



表面科学が拓くトライボロジーの進歩 **Review**



Advances in Tribology Driven by Surface Science

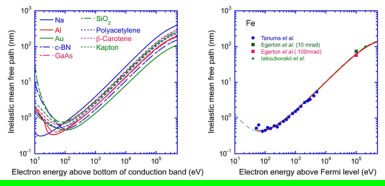
Shinya Sasaki
Vol. 21, Iss. 2, pp. 90-104 (2023)

放射光を用いた表面界面科学の進展 **Review**

Progress of Surface and Interface Science Using Synchrotron Radiation

Toyohiko Kinoshita
Vol. 21, Iss. 2, pp. 105-113 (2023)

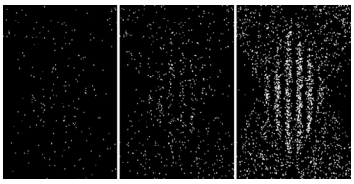
表面分析における電子非弾性散乱 **Review**

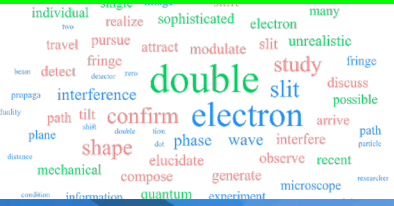


Electron Inelastic Scattering in Surface Analysis

Shigeo Tanuma
Vol. 21, Iss. 2, pp. 114-120 (2023)

電子波を用いた高度なダブルスリット干渉実験 **Review**



Sophisticated Double-Slit Interference Experiments Using Electron Waves

Ken Harada, Yoshio Takahashi
Vol. 21, Iss. 2, pp. 121-127 (2023)